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Takashi Goto belongs to New Industry Creation Hatchery Center, Tohoku University, Japan and State Key Laboratory of Advanced Technology for Materials Synthesis and Processing, Wuhan University of Technology, China. He received a B.S., M.S. and Doctor degree in Materials Science from Tohoku University. He has published more than 800 papers on sintering, chemical vapor deposition (CVD) and melt growth of ceramics. His research interest is material manufacturing by CVD, spark plasma sintering and melt growth. He is a fellow of the American Ceramic Society and the Ceramic Society of Japan and an academician of the World Academy of Ceramics and the Asia Pacific Academy of Materials. He is president of the International Ceramic Federation (ICF) and general editor/editor-in-chief of Journal of Asian Ceramic Societies and an associate editor of Materials Letters.